## **EAST Search History**

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L2	317506	("313"/\$ or "345"/\$ or "257"/\$).ccls.	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L3	191101	L2 and substrate	US-PGPUB; USPAT	OR	ON	2006/05/26 10:19
L4	25701	L3 and pixel	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L5	948	L4 and dummy	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L6	406	L5 and organic	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L7	223 ·	L6 and (seal or sealing or sealed or sealant)	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L8	178	L7 and (connecting or connection)	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L9	132	L8 and (capacitor or capacitive)	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L10	113	L9 and drain and source	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L11	113	L10 and gate	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L12	92	L11 and (calcium or ca or aluminum or magnesium or mg)	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L13	84	L12 and (ito or izo or (indium with tin) or (indium with zinc))	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L14	84	L13 and (insulating or insulation or insulative)	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L15	52	L14 and @ad<"20031224"	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L16	32	L14 and @ad>"20031223"	US-PGPUB; USPAT	OR	ON	2006/05/26 10:16
L17	1117	(313/503).CCLS.	US-PGPUB; USPAT	OR	OFF	2006/05/26 10:16
L18	3237	(313/504):CCLS.	US-PGPUB; USPAT	OR	OFF	2006/05/26 10:16
L20	3204	(313/506).CCLS.	US-PGPUB; USPAT	OR	OFF	2006/05/26 10:16
L21	1079	(313/512):CCLS.	US-PGPUB; USPAT	OR	OFF	2006/05/26 10:16
L22	2137	(315/169.3).CCLS.	US-PGPUB; USPAT	OR	OFF	2006/05/26 10:16
L23	1681	(257/40):CCLS.	US-PGPUB; USPAT	OR	OFF	2006/05/26 10:16
L24	651136	organic	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/26 10:16
L25	5273	L24 and pixel	EPO; JPO; DERWENT;	OR	ON	2006/05/26 10:16
L26	43	L25 and dummy	IBM_TOB EPO; JPO;	OR	ON	2006/05/26 10:16
	:::::::::::::::::::::::::::::::::::::::		DERWENT; IBM_TDB			
L27	12	L26 and (tft or transistor)	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/26 10:16

## **EAST Search History**

L28	1890	L25 and (tft or transistor)	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/26 10:16
L29		L28 and (seal or sealant or sealing or sealed)	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/26 10:16
L30	53	L29 and electrode	EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2006/05/26 10:16
L31	49	L30 and substrate	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/26 10:16
L32	1	("20020158577").PN.	US-PGPUB; USPAT	OR	OFF	2006/05/26 10:19